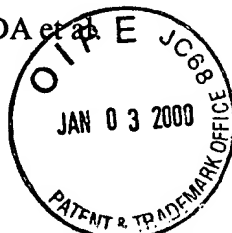


PATENT
2342-111P

IN THE U.S. PATENT AND TRADEMARK OFFICE

APPLICANT: Kazuyuki TOYODA et al
APPL. NO.: 08/905,971
FILED: August 5, 1997
FOR: SUBSTRATE PROCESSING APPARATUS

GROUP: 1763
EXAMINER: R. Zervigon



#9A
1/7/00
mw

REPLY UNDER 37 C.F.R. §1.111

Assistant Commissioner for Patents
Washington, D.C. 20231

Date: January 3, ²⁰⁰⁰~~1999~~ (Monday)

Sir:

In response to the Final Office Action dated July 1, 1999, the period for response having been extended for three (3) months to January 3, 2000, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

RECEIVED
JAN-5-2000
TC 170 MAIL ROOM

IN THE SPECIFICATION:

Please amend the specification as follows:

Page 4

Line 18, before "first" insert --a--; replace "means" with --device--;

Page 5

Line 18, before "second" insert --a--;

Line 19, replace "means" with --device--;

Line 26, before "first" insert --a--; replace "means" with --device--;